



Software solutions for  
optimizing micro & nano  
fabrication processes



## First Announcement

# BEAMeeting 2019 at the MNE, Rhodes, Greece Technical Workshop & Discussion

Date: Monday 23rd September, 2019  
Place: [Rhodes Palace Hotel](#)  
Time: Monday, 09:00 until 12:30  
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Our BEAMeetings are focussed on E-Beam lithography, data-preparation, PEC, process correction, and lithography simulation. The meeting is a technical exchange platform for BEAMER users and those who are interested in BEAMER and other GenISys software. Please bring inputs on any topic of your preference, User presentations on applications, solutions for specific issues and needs are very welcome. Please let us know if you would like to give a short presentation. The final agenda will be based on your inputs. Do not hesitate to communicate requests and suggestions to make the BEAMeeting most interesting and valuable for the BEAMER community.

The BEAMeeting is free of charge – lunch is included. Further information regarding venue, program etc. will be mailed when available.

The BEAMeeting will be held at the [Rhodes Palace Hotel](#).

For registration or queries, please contact: Alexandra Grashei - [assistant@genisys-gmbh.com](mailto:assistant@genisys-gmbh.com).

See you Rhodes, Greece, in September – The GenISys Team